

PATENT

0941-0721PUS2

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Jung-Chuan CHOU et al Conf.:
Appl. No.: NEW Group:
Filed: March 29, 2004 Examiner: UNASSIGNED
For: A-C:H ISFET DEVICE MANUFACTURING METHOD, AND
TESTING METHODS AND APPARATUS THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 29, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes: Amendments to the Specification and Amendments to the Claims and Remarks.